



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 10/678,168

Filed: October 6, 2003

For: CRYSTALLINE SEMICONDUCTOR  
THIN FILM, METHOD OF  
FABRICATING THE SAME,  
SEMICONDUCTOR DEVICE, AND  
METHOD OF FABRICATING THE  
SAME

) Group Art Unit: 2811

) Examiner: Unassigned

) CERTIFICATE OF MAILING  
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INFORMATION DISCLOSURE STATEMENT  
AND NOTICE OF RELATED APPLICATIONS

Honorable Commissioner of Patents

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Sir:

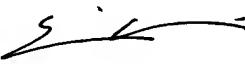
In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing a reference known to Applicant and requests that the reference be made of record in the above identified application. A copy of the reference listed is submitted herewith in accordance with 37 C.F.R. 1.98(a).

The Examiner's attention is directed to related Patent Application Serial Nos. 09/352,362 Filed July 13, 1999 and 09/352,373 Filed July 13, 1999.

This Information Disclosure Statement is being submitted before the issuance of a first Office Action on the merits, therefore, no fee is required.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 50-2280. A duplicate copy of this sheet is attached.

Respectfully submitted,

  
Eric J. Robinson  
Reg. No. 38,285

Robinson Intellectual Property Law Office, P.C.  
PMB 955  
21010 Southbank Street  
Potomac Falls, Virginia 20165  
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<p>Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information if it does not display a valid OMB control number.</p> <p>Substitute for form 1449A/PTO</p> <p><b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b></p> <p>(use as many sheets as necessary)</p> <p style="text-align: center;"><i>MAY 05 2004</i></p>				<b>Complete if Known</b>	
				Application Number	10/678,168
				Filing Date	October 6, 2003
				First Named Inventor	Shunpei YAMAZAKI et al.
				Group Art Unit	2811
				Examiner Name	Unassigned
				Attorney Docket Number	0756-7208
Sheet	1	of	1		

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**U.S. PATENT DOCUMENTS**

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**FOREIGN PATENT DOCUMENTS**

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#### **OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS**

OTHER PRIOR ART - NON-PATENT LITERATURE			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
		Specification, Claims, Abstract, and Drawings of U.S. Serial No. 09/352,362 Filed July 13, 1999, "Crystalline, Semiconductor Thin Film, Method of Fabricating the Same Semiconductor Device, and Method of Fabricating the Same"	
		Official Filing Receipt, Specification, Claims, Abstract, and Drawings of U.S. Serial No. 09/352,373 Filed July 13, 1999, "Crystalline Semiconductor Thin Film, Method of Fabricating the Same, Semiconductor Device, and Method of Fabricating the Same"	

Examiner Signature		Date Considered	
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**\*EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in accordance with MPEP 609. Include copy of this form with next communication to applicant.

<sup>1</sup> Unique citation designation number. <sup>2</sup> See attached Kinds of U.S. Patent Documents. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

Is this application in English?  Is this application in Spanish?  Is this application in both English and Spanish?

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